



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 18, 2022	
IGI Report Number	LG555202799
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.32 X 6.31 X 4.59 MM

GRADING RESULTS

Carat Weight	1.58 CARAT
Color Grade	H
Clarity Grade	VS 1

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

Inscription(s) LABGROWN LG555202799

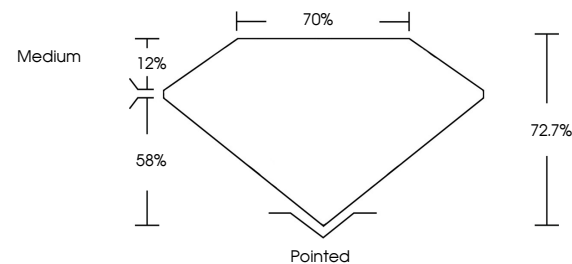
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.
Type IIa

LABORATORY GROWN DIAMOND REPORT

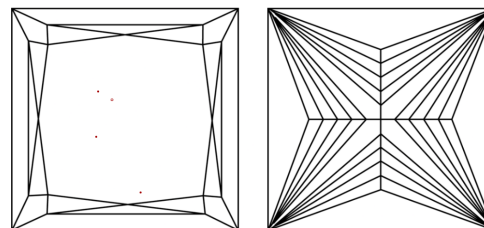
LG555202799

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

LABORATORY GROWN
DIAMOND REPORT

GRADING SCALES

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

COLOR

D E F G H I J Faint Very Light Light

LASERSCRIBESM

Sample Image Used



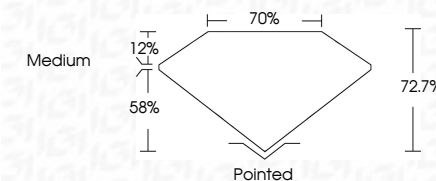
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GRADING RESULTS	
Carat Weight	1.58 CARAT
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ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LABGROWN (157) LG555202799

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.
Type IIa



	November 18, 2022
(G) Report No LG6592799	
PRINCESS CUT	
3.39 X 4.31 X 4.59 MM	
Carat Weight	1.58 CARAT
Color Grade	H
Clarity Grade	VS 1
Depth	72 %
Girdle	70%
	Medium
Culet	Poished
Rach	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LARGOWAIN LAB LG6592799
Comments:	This Laboratory Grown Diamond was created by Chemical Vapor Deposition CVD growth process and may include additional heat treatment.
	Type Ia